

Paper No. __

UNITED STATES PATENT AND TRADEMARK OFFICE

BEFORE THE PATENT TRIAL AND APPEAL BOARD

TAIWAN SEMICONDUCTOR MANUFACTURING COMPANY, LTD.
(TSMC) and SAMSUNG ELECTRONICS, CO. LTD.
Petitioner

v.

DSS TECHNOLOGY MANAGEMENT, INC.
Patent Owner

Patent 5,652,084
IPR2014-01030¹

Title: METHOD FOR REDUCED PITCH LITHOGRAPHY

PETITIONERS' REQUEST FOR ORAL ARGUMENT

¹ Case IPR2014-01493 has been joined with this proceeding.

Pursuant to 37 C.F.R. § 42.70(a), Petitioners respectfully request oral argument on the issues set forth below. Oral argument is presently scheduled for August 12, 2015 (Paper 8, Scheduling Order). Petitioners specify the following issues to be argued:

- I. Whether claims 1-8, 12, 15, and 16 are unpatentable under 35 U.S.C. § 102(b) as anticipated by Jinbo;
- II. Whether claim 9 is unpatentable under 35 U.S.C. § 103(a) as obvious over Jinbo and McCogin;
- III. Whether claims 10 and 11 are unpatentable under 35 U.S.C. § 103(a) as obvious over Jinbo and Matthews;
- IV. Reply to any arguments raised in Patent Owner's Response;
- V. Respond to any issues specified by Patent Owner in its request for oral argument; and
- VI. Respond to Patent Owner's presentation on all matters.

Dated: June 26, 2015

Respectfully submitted,

/David M. O'Dell/
David M. O'Dell
Lead Counsel for Petitioner TSMC
Registration No. 42,044

CERTIFICATE OF SERVICE

Pursuant to 37 C.F.R. § 42.6(e), this is to certify that I caused to be served a true and correct copy of the foregoing "Petitioners' Request for Oral Argument", as detailed below:

Date of service June 26, 2015

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